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## \*BIBDATASHEET\*

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## APPLICANTS

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Kazutaka Nakayama, Hayami-gun, JAPAN;

\*\* CONTINUING DATA ..... *MK (NONE)*\*\* FOREIGN APPLICATIONS ..... *MK (verified)*

JAPAN 2001-059776 03/05/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/27/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no Met after Allowance <i>[Signature]</i> Examiner's Signature	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 2
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## TITLE

Method and device for removing particles on semiconductor wafers

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